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Yoden et al.

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(54) **ION EXCHANGING APPARATUS**

(75) Inventors: **Mitsuru Yoden**, Tokyo (JP); **Mikio Sugano**, Tokyo (JP); **Kazuhiko Saiki**, Tokyo (JP); **Reo Matsutani**, Tokyo (JP); **Kazuhiro Nishikawa**, Tokyo (JP)

(73) Assignee: **ORGANO CORPORATION**, Tokyo (JP)

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Primary Examiner — Matthew O Savage
(74) *Attorney, Agent, or Firm* — Knobbe Martens Olson & Bear LLP

(57) **ABSTRACT**

The present invention aims at limiting the pressure loss and smoothly discharging water treated by ion exchangers to the outside of the apparatus. Ion exchanging apparatus **1** has outer vessel **3** that has inner space **2**; and ion exchanger support **4** that separates at least a part of inner space **2** into upper space **2***a* and lower space **2***b* and that can support ion exchangers to be loaded in upper space **2***a*. At least a part of an upper surface of the ion exchanger support is made from at least one screen which supports the ion exchangers and
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